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Substitute for form 1449B/PTO		<i>Complete if Known</i>		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	10/616,479	
		Filing Date	7/8/2003	
		First Named Inventor	Thomas M. McCleskey	
		Art Unit		
		Examiner Name		
Sheet		of	Attorney Docket Number	S-100,631

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published (when known)	T ²
/TY/		Lang, "Chemical Solution Routes to Single-Crystal Thin Films," Science, no. 5277, vol. 273, pp. 903-909, 1996.	
/TY/		Schwartz, "Chemical Solution Deposition of Perovskite Thin Films," Chem. Mater., vol. 9, no. 11, pp 2325-2340, 1997.	
Examiner Signature	/Tae Yoon/		Date Considered
		04/19/2007	

¹ Applicant's unique citation designation number (optional).

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